

"Optoelectronic module with integrated loop-back capability"

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The present invention relates to optical
5 telecommunication systems and, more specifically, is
related with monitoring performance of such systems.

In optical telecommunication systems, bit error
ratio (BER) and uptime are important measures of the
quality of the system. For example, some system
10 elements are required to have uptimes of 99.995% or
99.999%, including both planned and unplanned downtime.

An important way of ensuring high uptime values is
to continually monitor the performance of the system
elements to locate faults, allowing them to be put
15 right quickly, and to identify defects before they
become faults allowing them to be corrected without any
unplanned downtime.

A way of monitoring the performance of system
elements is by loop-back testing. Such a testing
20 technique provides for a signal destined for a remote
location to be instead directed to a nearby receiver;
in the case of a transceiver, the signal launched from
its transmitter may be returned to its receiver. Often
the signal is attenuated to simulate the losses in the
25 optical telecommunication system.

Generally, loop-back testing requires a technician
to physically remove the connectors of the optical
telecommunication system and replace them with a so-
called patchcord, or the connectors of a variable
30 optical attenuator (VOA). The system can then be tested
in the loop-back condition and finally the patchcord,
or the connectors of the VOA, can be removed and the
system connectors replaced.

Figure 1 shows a transceiver module including
35 transmitter and receiver sub-modules T and R, as well

as the associated control electronics E integrated into a housing H to transmit digital input signals I and receive digital output signals O via an optical communication system connected to the housing H via a transmitter connector C1 and a receiver connector C2.

This arrangement is thoroughly conventional in the art and does not require to be described in detail herein.

Figure 1 shows a typical loop-back testing condition for the system in question where the optical telecommunication system has been disconnected and replaced by a patchcord arranged to receive light from the transmitter T via the connector C1 and re-direct it to the receiver R via the connector C2.

The patchcord typically includes a length of an optical fibre F (currently designated loop-back fibre), possibly including a variable optical attenuator or VOA that attenuates the light. Resorting to such an arrangement requires a technician to physically remove the connectors of the optical telecommunication system and replace them with the patchcord. The system can then be tested in the loop-back condition and finally the patchcord can be removed and the system connectors replaced.

This is a laborious and time-consuming process.

The need is therefore felt for solutions overcoming the disadvantages of the prior art considered in the foregoing.

According to the present invention such an object is achieved by means of an optoelectronic integrated loop-back arrangement as called for in the claims that follow.

The module of the invention includes, as an integral part thereof, a selectively activatable loop-back arrangement. Preferably, the loop-back arrangement

includes one or more internal optical switches adapted to connect the transmitter and receiver included in the module to the optical telecommunication system, in which case the transceiver module functions as a
5 standard transceiver module. Alternatively, the loop-back arrangement can connect the transmitter to the receiver to allow loop-back testing. The loop-back arrangement can be controlled remotely over the digital interface to the transceiver. The intervention of a
10 technician is thus no longer required and loop-back testing can be performed in a quick and cheap manner.

The invention will now be described, by way of example only, with reference to the annexed drawings, wherein:

15 - Figure 1, relating to the prior art, has been already described in the foregoing,

- Figures 2a and 2b show the general arrangement of a loop-back testing facility according to the invention with reference to current operation of the
20 telecommunication system and to the testing phase, respectively,

- Figures 3a and 3b illustrate in greater detail an optoelectronic circuit layout adapted for use in certain embodiments of the invention,

25 - Figures 4 to 6 refer to various further alternative embodiments of the invention.

Elements/parts identical or equivalent to those already referred to in connection with figure 1 have been indicated throughout figures 2 to 6 using the same
30 references, thus making it unnecessary to identify and describe those elements/parts again.

Figures 2a and 2b show schematically a transceiver module with integrated optical switches S1 and S2. The switches S1 and S2, preferably together with a length
35 of an optical waveguide OW extending between the

switches S1 and S2, are adapted to selectively define a loop-back circuit connecting the transmitter T to the receiver R.

Specifically, in the condition shown in figure 2a,
5 the optical switches S1 and S2 are set to allow propagation of optical radiation:

- from the transmitter T into the optical telecommunication system via the connector C1, and
- from the optical communication system into the
10 receiver R via connector C2.

In the operating condition shown in figure 2b, the optical radiation from transmitter T, instead of being directed towards connector C1, is switched via the optical switch S1 over the optical waveguide OW and on
15 into the receiver R via the optical switch S2.

Figures 3a and 3b, that essentially correspond to figure 2a and 2b, respectively, show in more detail a transceiver module with integrated optical switches S1, S2 and a loop-back circuit associated therewith.

20 In this embodiment, light from the transmitter T (typically a laser source) is collimated via an optical system such as a lens V1 to be then propagated through an (optional) isolator IS arranged at the upstream of the loop-back arrangement and then focussed through a
25 further lens V2 into the connector C1 to be propagated into the optical communication system (not shown).

Similarly, light received from the optical telecommunication system via the connector C2 is collimated and then focussed via further lenses V3 and
30 a lens V4 into the receiver R (this is typically an opto-electrical converter such as a photodiode or a phototransistor).

In a first embodiment, the optical switches essentially comprise mirrors M1 and M2 adapted to be
35 selectively positioned in the transmitter collimated

beam and the receiver collimated beam to reflect the light from the transmitter laser T to the receiver photodetector R providing a loop-back mode.

5 An optional, preferably variable optical attenuator VOA is positioned between the mirrors M1 and M2 to attenuate the light.

10 Propagation of light from the mirror M1 to the mirror M2 can be unguided (that is not through an optical waveguide proper), the variable optical attenuator VOA being in any case arranged to be interposed in the optical path from mirror M1 to mirror M2.

15 It will be appreciated that the representation of the mirrors M1 and M2 in shadow lines in figure 3a may be purely notional in that - in the operating condition shown therein - the mirrors M1 and M2 may in fact be moved away from the propagation path between the lenses V1 and V2 and the propagation path between lens V3 and lens V4.

20 Any mechanical actuator known in the art can be utilised for moving the mirrors M1 and M2 between a first "passive" i.e. non-reflecting condition shown in figure 3a and a second "active" i.e. reflecting condition shown in figure 3b where the mirror M1
25 actually prevents radiation from laser source T from propagating towards the lens V2 and the connector C1.

30 In the operating conditions shown in figure 3b such radiation is reflected from the mirror M1 towards the variable optical attenuator VOA (if present) and then towards the mirror M2 to be then reflected back towards the photodetector R through the lens V4.

35 The art of micro-machining provides several mechanisms adapted for the purpose indicated, thus making it unnecessary to provide a detailed discussion herein. Specifically, mechanisms that utilize sliding

actuators are well known to those of skill in the art of micro machining. In addition, the mirrors M1, M2 can be positioned on "flip-up" or rotary actuators.

For a more detailed discussion of these
5 techniques, reference may be had to Ming C. Wu, "Micromachining for optical and optoelectronic Systems", IEEE 85, no. 11, pp 1833-1856, 1997.

Those of skill in the art will also appreciate that alternative embodiments of either or both mirrors
10 M1 and M2 may not provide for such mirrors being rendered selectively movable between a "passive" position where the mirror is disengaged (i.e. displaced) with respect to the optical path of propagation from the source T and the receiver R (e.g.
15 figure 3a) and an "active" position where the mirror does intercept such an optical path (e.g. the position shown in figure 3b). For instance, either or both of the mirrors M1 and M2 can be implemented in the form of mirrors adapted to be selectively switched between a
20 first "passive" state where they do not exhibit any appreciable reflective effect (thus permitting optical radiation from the source T and/or towards the receiver R to freely propagate therethrough) and a second "active" state where the mirror exhibits a reflective
25 surface adapted to reflect radiation from the transmitter T towards the receiver R. Selectively activatable mirrors of this kind are known in the art as witnessed e.g. by Hikmet, R.A.M., Kemperman, H., Electrically switchable mirrors and optical components
30 made from liquid-crystal gels, *Nature*, Volume 392, Issue 6675, 1998, Pages 476-479. The general layout shown in figure 3b lends itself to another embodiment of the invention, wherein the mirrors M1 and M2 can be realised in the form of fixed,
35 partially silvered mirrors that allow e.g. 96% straight

through coupling and 4% reflection, that is mirrors having a high straight through coupling/reflection ratio. By "high", a ratio is meant herein of the order of e.g. 20 or more.

5 Having regard to the straight through coupling value indicated, the main signal paths from the transmitter T to the connector C1 and from the connector C2 to the receiver R are little impaired by the presence of the mirrors M1 and M2.

10 Even though relatively minor (e.g. 4% reflection) the reflection at the mirror M1 causes a portion of the radiation generated by the transmitter T to be reflected towards the variable optical attenuator VOA. Any radiation passing through the variable optical
15 attenuator may thus be directed towards the mirror M2. Again, even though relatively minor (e.g. 4% reflection), the reflection at the mirror M2 causes a portion of the radiation from the variable optical attenuator VOA to be reflected by the mirror M2 towards
20 the receiver R.

 A loop-back path is thus established from the transmitter T to the receiver R which has a loss of .002 or 26dB (mirrors S1 and S2), plus the loss of the variable optical attenuator VOA. This loss can be
25 selectively adjusted to be high (say >25 dB) under normal operation and low (say <2dB) under loop back test operation.

 When the loss of the variable optical attenuator VOA is adjusted to be high, the overall loss of the
30 loop-back path is very high (e.g. in the excess of 50 dB), so that no appreciable level of optical radiation from the transmitter T reaches the receiver R.

 Conversely, when the loss of the variable optical attenuator VOA is adjusted to be low, the overall loss
35 of the loop-back path is in the range of 28 dB. Under

these conditions, a level of optical radiation from the transmitter T reaches the receiver R that is high enough to enable loop-back testing to be carried out in a thoroughly satisfactory manner by simply ensuring
5 that no interfering optical radiation from outside reaches the receiver R through the connector C2 while testing is being performed.

This technique, based on the recognition that the path loss capability of a transceiver might typically
10 be of the order of 30 dB from the transmitter T to the receiver R, avoids moving parts; only the VOA's attenuation changes which could be e.g. a liquid crystal cell.

Figure 4 shows a further alternative embodiment
15 where, instead of being interposed between the mirrors M1 and M2 as shown in figure 3, the variable optical attenuator VOA is arranged in the propagation path between the transmitter T and the mirror M1. This is preferably achieved by interposing the variable optical
20 attenuator VOA between the isolator IS (or the lens V1) and the mirror M1.

The arrangement shown in figure 4 has the advantage that the variable optical attenuator VOA can control the light intensity both when propagated into
25 the optical telecommunication system as well as in the loop-back mode.

Figure 5 shows another alternative embodiment wherein the transmitter or source T plus the connector C1, on the one hand, and the connector C2 plus the
30 receiver R, on the other hand, form two rectilinear propagation paths arranged in a cross-wise pattern. The two propagation paths thus defined cross at a position where a single reflective mirror M12 may be located by being selectively displaced between a "passive" and an
35 "active" position. Alternatively, the mirror M12 may be

of the kind adapted to be alternatively and selectively rendered transparent and reflective as discussed in the foregoing.

When the mirror M12 is in the "passive" state,
5 optical radiation generated from the laser source T is propagated through the lens V1, the isolator IS and the variable optical attenuator VOA, to traverse the mirror M12 and reach the lens V3 to be focussed into the connector C1. Similarly, incoming radiation from the
10 connector C2 passes through the lens V3 as well as the mirror M12 to reach the lens V4 to be focussed onto the photodetector R.

When the mirror M12 is in the "active" reflective state, optical radiation from the laser source T,
15 instead of being propagated through the mirror towards the lens V2 and the connector C1, is reflected by the mirror M12 towards the lens V4 and the photodetector R to complete the loop-back path.

Figure 6 shows still another embodiment where the
20 switches S1 and S2 as well as the loop-back optical waveguide OW are integrated in a planar lightwave circuit (PLC).

PLCs are well known and are described e.g. in "Silica-based single-mode waveguides on silicon and
25 their application to guided-wave optical interferometers", Takato, N., Jinguji, K., Yasu, M., Toba, H., Kawachi, M; Journal of Lightwave Technology, Volume 6 Issue 6, June 1988, Pages 1003-1010; "Recent progress on silica-based thermooptic switches 1999,
30 Pages 485-486; "Silica-based planar lightwave circuits"; Himeno, A., Kato, K., Miya, T; IEEE Journal on Selected Topics in Quantum Electronics; Volume 4 Issue 6; Nov.-Dec. 1998; Pages 913-924.

Of course, without prejudice to the basic
35 principle of the invention, the details of construction

and the embodiments may widely vary with respect to what has been described and illustrated purely by way of example, without departing from the scope of the present invention. Also, it will be appreciated that,
5 according to the current meaning in the art, designations such as "optical", "light" and so on are in no way restricted to the sole domain of visible light radiation. These designations do in fact apply to the whole of the wavelength domains adapted for use in
10 optical communications, including e.g. the UV and IR domains.